NEASURING SYSTEMS

Quick Vision series

QV Active	N-002
QV Apex / Hyper QV	N-003
QV STREAM PLUS / QV ACCEL	N-004
ULTRA QV / Hyper QV WLI	N-005
QV TP	N-006
QVH Apex / Hyper QVH / QVH ACCEL /QVH STREAM PLUS	N-007

Micro form measuring system

UMAP Vision System	N-008-009
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N-011

Data Processing Software

QVPAK N-010

QUICK SCOPE series

QS-LZ / AFC

QUICK IMAGE series

QI N-012

Data Processing Software ซอฟแวร์

ละเอียด

Quick Scope Series เครื่องวัดขึ้นงาน ละเอียด

Quick Image Series เครื่องวัดขึ้นงาน ละเอียด

เครื่องวัดขึ้นงานละเอียด

Mitutoyo

เครื่องวัดชิ้นงานละเอียด

QV Active

SERIES 363 — CNC Vision Measuring System

VISION MEASURING SYSTEMS

- · Cost effective, multifunction, CNC Vision Measuring System.
- Usability has been improved by adopting a color camera and 8-step zoom optics.
- A touch-probe model can seamlessly perform non-contact and contact measurement.
- The zoom ratio of 7X (14X at maximum by changing the fixedmagnifi cation objective lens) enables a wide range of inspection from wide view measurement at low magnifi cation



Optical	magnifi cation	0.5X	0.65X	0.75X	0.85X	0.98X	1X	1.28X	1.3X	1.5X	1.7X	2X	2.25X	2.5X	ЗХ	3.5X	3.75X	4X	5X	5.25X	7X
View fie (mm)	ld Horizontal (H) Vertical (V)	13.60 10.80	10.46 8.31	9.07 7.20	8.00 6.35	6.94 5.51	6.80 5.40	5.31 4.22	5.23 4.15	4.53 3.60	4.00 3.18	3.40 2.70	3.02 2.40	2.72 2.16	2.27 1.80	1.94 1.54	1.81 1.44	1.70 1.35	1.36 1.08	1.30 1.03	0.97 0.77
Total ma	agnifi cation (on the monitor)	13.20	17.10	19.80	22.40	25.80	26.40	33.70	34.30	39.50	44.80	52.70	59.30	65.90	79.10	92.30	98.90	105.50	131.80	138.40	184.50
SU	1X objective (optional) Working distance	•	•		•		•	74	mm	•		•		•		•					
	1.5X objective (standard accessory) Working distance			•		•		•	F		42	mm	•		•		•			•	
	2X objective (optional) Working distance						•		•		•	•	42	mm	•			•	•		-

Note: The total magnification indicates the magnification on the monitor when the size of the QVPAK video window is 178.8x143.0 mm (default).

Order No.		QV Active 202	QV Active 404			
Туре		Standard model	Standard model			
Measuring range (XxYxZ)		250x200x150 mm (250x200x118 mm: when 1X objective is used)	400x400x200 mm (400x400x168 mm: when 1.5X objective is used)			
Observation unit		Zoom unit (8 positions)				
Imaging device		Color CMOS camera				
	E1X, E1Y	(2+3L/1000)μm				
	E1Z	(3+5L/1000)µm				
Accuracy *	E2	(2.5+4L/1000)μm				
	Accuracy guaranteed with optics specified	1.5X objective and	1 5.25X Zoom ratio			
Touch-trigger probe measuring accuracy*		-	_			
Accuracy guaranteed temperature r	ange	20±1 ^º C	20±1 ^o C			
Temperature compensation function	1	_	_			

^{*} Inspected to a Mitutoyo standard. L = length between two arbitrary points (mm)

MeasurLink® ENABLED Data Management Software by Mitutoyo

VISION MEASURING SYSTEMS

เครื่องวัดชิ้นงานละเอียด

Mitutoyo

MeasurLink® ENABLED

Data Management Software by Mitutoyo

เครื่องวัดชิ้นงานละเอียด **QV** Apex / Hyper **QV CNC Vision Measuring System**



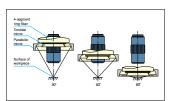
- A high-productivity CNC Vision Measuring System that can precisely and effectively perform a series of tasks from dimensional calculation to form
- The part program editing, such as changeover of the workpiece or correcting errors, is easy and straight
- High specifi cations such as contour measurement or non-contact measurement are
- covered.

 **TAF (Tracking Auto Focus) automatically follows changes in the height of the object being measured. TAF eliminates the the time that otherwise would be wasted in re-establishing focus multiple times, resulting in shorter measurement time.

Programmable ring light

Fine control of obliquity and direction provides

illumination optimal for measurement.
Obliquity can be arbitrarily set in the range from 30° to 80°. Illumination can be controlled independently in every direction, back and forth, right and left.



The programmable ring light shows the effect of a finely stepped section and the enhanced contrast of an inclined plane.



Measurement example of IC package terminal bottom width



Co-axial light



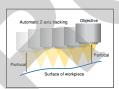
Image with programmable ring light

Tracking Auto Focus (TAF)

The TAF feature focuses continuously, adjusting to changes in the height of the object being measured. Automatic tracking of surface waves and warpage (in the Z-axis height direction) improves measurement throughput. The feature also cuts out the hassle of focusing during manual measurement, reducing the work burden for measuring system operators.

Auto focus

Note: Continuous measurement of displacement is not performed



Laser	Semiconductor laser (peak wavelength: 690 nm)
Laser safety	Class 2 (JIS C6802:2014, EN/IEC 60825-1:2014)

Objective coaxial autofocusing (knife-edge method)

Hyper QV 404

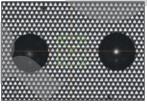
High-Performance Multi-Auto Focus

The QV Series is equipped with a high-performance image auto focus function as standard. Image auto

focus is used to guarantee accuracy.

Thanks to the availability of various auto focus tools, the optimal focus for each surface texture and measured feature can be selected, which makes it possible to perform highly reliable height measurements.

Pattern Focus



The pattern focus reticule enables focusing on low contrast or mirrored surfaces, or transparent objects.

Edge Focus



Robust edge detection methods for multiple lighting techniques are available with edge focus.

Surface Focus

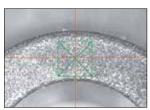


Image auto focus can be used to measure the height of a chosen area, which makes it possible to perform stable height measurements that are minimally affected by the roughness of machined surfaces and other similar surfaces.

QV Apex

Order No.		QV Apex 302	QV Apex 404	QV Apex 606				
Measuring range (XxYxZ)		300x200x200 mm 400x400x250 mm		600x650x250 mm				
Observation Unit PPT1X-2X-6X								
Imaging Dev	vice	B&W CCD (1/2 inch) or 3CCD color (1/3 inch)						
	E1X, E1Y		(1.5+3L/1000)µm					
Accuracy*	E1Z		(1.5+4L/1000)µm					
	E2XY	(2+4L/1000)μm						

Hyper QV (Specifications other than as quoted in the table are the same as the QV Apex specifications.)

Order No.		Hyper QV302 Hyper QV404 Hyper QV6					
Imaging Device		B&W CCD (1/2 inch)					
	E1X, E1Y		(0.8+2L/1000)µm				
Accuracy*	E1Z	(1.5+2L/1000)μm					
	E2XY	(1.4+3L/1000)µm					

^{*} Inspected to a Mitutoyo standard. L = length between two arbitrary points (mm)

VISION MEASURIG SYSTEMS เครื่องวัดชิ้นงานละเอียด

Vision Measuring System เครื่องวัดชิ้นงาน ละเอียด

Micro Form Measuring System เครื่องวัดชิ้นงาน

ละเอียด

Data Processing Software ซอฟแวร์

Quick Scope Series เครื่องวัดชิ้นงาน ละเอียด

Quick Image Series เครื่องวัดชิ้นงาน ละเอียด

ละเอียด **Data Processing** Software

ซอฟแวร์

Quick Scope Series เครื่องวัดขึ้นงาน ละเอียด

Quick Image Series เครื่องวัดขึ้นงาน ละเอียด

Mitutoyo

เครื่องวัดชิ้นงานละเอียด **QV STREAM PLUS**

SERIES 363 — Non-stop CNC Vision Measuring System

- This non-stop CNC Vision Measuring System has achieved a reduction of measurement time compared with the normal measurement mode.
- QV STREAM PLUS employs an image capturing method that operates without stopping the stage to achieve signifi cant throughput improvement.
- In the XY measurement, the throughput has improved 5 times compared to the conventional model, achieving a major reduction in measurement time.









QV STREAM PLUS 606

Order No.		QV STREAM PLUS302	QV STREAM PLUS404	QV STREAM PLUS606		
Measuring r	range (XxYxZ)	300x200x200 mm	300x200x200 mm 400x400x250 mm			
Observation Unit		PPT1X-2X-6X				
Imaging Device B&W CCD (1/2 incl		B&W CCD (1/2 inch)				
	E1X, E1Y		(1.5+3L/1000)µm			
Accuracy*	E1Z	(1.5+4L/1000)µm				
	E2XY	(2+4L/1000)μm				
Tracking auto focus device Optional						

^{*} Only one of the illumination functions (reflected, transmitted, and PRL illumination) can be set in STREAM mode. The 4-way PRL illumination can be set to 4-direction lighting or single-direction lighting.

เครื่องวัดชิ้นงานละเอียด **QV ACCEL Large CNC Vision Measuring System**

- A large CNC Vision Measuring System suitable for measuring large, thin workpieces.
- The model best suited to the workpiececan be selected from
- a measuring range of 800x800 mm to 1500x1750 mm.
 In measurement, highspeed acceleration and deceleration is achieved by adopting the center drive method.

 Thanks to the moving gantry design of QV ACCEL, the stage does not need to move, therefore workpiece fi xturing can be



QV ACCEL 808

Order No.		QV ACCEL808	QV ACCEL1010				
Measuring rang	e (XxYxZ)	800x800x150 mm	1000x1000x150 mm				
Observation Un	it	PPT1X	-2X-6X				
Imaging Device		B&W CCD (1/2 inch)					
	E1X, E1Y	(1.5+3L/	1000)μm				
Accuracy*	E1Z	(1.5+4L/1000)μm					
	E2XY	(2.5+4L/1000)μm					
Repeatability*	E2XY	3 <i>σ</i> =0.	.2 μm				
переагаріііту	E2XY	3 <i>σ</i> =0.7 μm					
Tracking auto fo	cus device	Optional					

^{*} Inspected to a Mitutoyo standard. L = length between two arbitrary points (mm)





VISION MEASURING SYSTEMS

เครื่องวัดชิ้นงานละเอียด

MeasurLink® ENABLED Data Management Software by Mitutoyo

เครื่องวัดชิ้นงานละเอียด **ULTRA QV404**

Ultra-High Accuracy CNC Vision Measuring System



- ULTRA QV404 PRO is an ultra-high accuracy CNC vision measuring system that offers the world's highest level of measurement accuracy, E1XY:
- (0.25+L/1000)µm.
 A high-rigidity, fi xed-bridge moving table design is adopted for the Y axis, and the X- and Y-axis guides have excellent wear resistance. The base is granite for high thermal stability.
- The high-precision scales are made of a crystallized glass whose expansion coefficient is almost zero,

 The high-precision scales are made of a crystallized glass whose expansion coefficient is almost zero, and feature a high resolution of 0.01 $\mu m.$ A vibration absorption system and floating ball-screw mechanism ensure a highly accurate Y-axis drive.



Order No.			ULTRA QV404			
Measuring range (XxYxZ)		400x400x200 mm			
Observation Unit		PPT1X-2X-6X				
Imaging Device		B&W CCD (1/2 inch)				
	E1X, E1Y		(0.25+L/1000)μm			
Accuracy (E1)*1	E1Z (Full stroke)		(1.5+2L/1000)μm (Range 200 mm)			
	E1Z (50 mm stroke)*2	(1.0+2L/1000)µm (Range 10 to 60 mm)				
Accuracy (E2)*1	E2XY	(0.5+2L/1000)µm				
Tracking auto focu	s device	Optional				

^{*1:} Inspected to a Mitutoyo standard. L = length between two arbitrary points (mm) *2: Verified at shipment from factory.







- The best-ever effi ciency and accuracy are achieved by combining imaging with the WLI optical head.
 High accuracy, dual-head vision measuring system
- equipped with a white light interferometer.

 For measurement that requires dimensional
- measurement and height/surface texture evaluation, high efficiency is offered by performing all tasks with one machine.



Order No.			Hyper QV WLI 302	Hyper QV WLI 404	Hyper QV WLI 606			
Measuring range Vision measuring area		300x200x190 mm	400x400x240 mm	600x650x220 mm				
(XxYxZ)		WLI measuring area*1	215x200x190 mm	315x400x240 mm	515x650x220 mm			
WLI optica	al head ı	unit						
View field (H	lxV)		5X lens: approx. 0.64x0.48 mm / 10X lens: approx. 0.32x0.24 mm / 25X lens: approx. 0.13x0.10 mm					
Repeatability	у		2 <i>σ</i> ≦ 0.08 μm					
Vision opt	ical hea	d unit						
Observation	unit		PPT1X-2X-6X					
Imaging dev	rice			B&W CCD (1/2 inch)				
	E1X, E	1Y	(0.8+2L/1000)µm					
Accuracy* E1Z			(1.5+2L/1000)µm					
	E2XY		(1.4+3L/1000)um					

Vision Measuring System เครื่องวัดชิ้นงาน ละเอียด

Micro Form Measuring System เครื่องวัดชิ้นงาน ละเอียด

Data Processing Software ซอฟแวร์

Quick Scope Series เครื่องวัดชิ้นงาน ละเอียด

Quick Image Series เครื่องวัดชิ้นงาน ละเอียด

^{*1:} Movable range of WLI optical head.
*2: Inspected to a Mitutoyo standard. L = length between two arbitrary points (mm)

Micro Form **Measuring System** เครื่องวัดชิ้นงาน

ละเอียด

ซอฟแวร์

Data Processing Software

Quick Scope Series เครื่องวัดขึ้นงาน ละเอียด

Quick Image Series เครื่องวัดขึ้นงาน ละเอียด

VISION MEASURING SYSTEMS

เครื่องวัดขึ้นงานละเอียด

Mitutoyo

เครื่องวัดชิ้นงานละเอียด

MeasurLink® ENABLED Data Management Software by Mitutoyo

CNC Vision Measuring System equipped with a Touch Trigger Probe

Non-contact and contact measurement on one machine

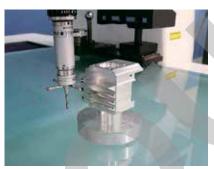
QV touch-trigger probe unit enables both vision measurement and touch-trigger probe measurement. **3D workpiece measurement**

Measures three-dimensional workpieces such as molded products resin molded products, machined products, and more.

Module change rack available

Easily change between vision and touch probe measurement with a module change rack.







Order No.		QVTP Active 202	QVTP Apex302 Hyper QVTP302	QVTP Active 404	QVTP Apex404 Hyper QVTP404	QVTP Apex 606 Hyper QVTP606
Measuring Accuracy*1	Vision	250x200x150 mm	300x200x200 mm	400x400x200 mm	400x400x250 mm	600x650x250 mm
(XxYxZ)	Common to Touch Trigger Probe	184x200x150 mm	234x200x200 mm	334x400x200 mm	334x400x250 mm	534x650x250 mm
Measuring accuracy*2 (Touch probe)	E1X, E1Y, E1Z	(2.4+3L/1000)μm	QVTP Apex: (1.8+3L/1000)µm Hyper QVTP: (1.7+3L/1000)µm	(2.4+3L/1000)μm	QVTP Apex: (1.8+3L/1000)μm Hyper QVTP: (1.7+3L/1000)μ m	

^{*1:} When a module change rack, a master ball, and a calibration ring are mounted, the measurement ranges are smaller than those in the table. Other specifications are the same as those for QV Apex, Hyper QV, and QV ACCEL.



Please contact our sales office for more details.
*2: Inspected by Mitutoyo standard. L = length between two arbitrary points (mm)

VISION MEASURING SYSTEMS

เครื่องวัดชิ้นงานละเอียด

Mitutoyo

MeasurLink® ENABLED

Data Management Software by Mitutoyo

QVH Apex / Hyper QVH / QVH ACCEL / QVH STREAM PLUS

CNC Vision Measuring System equipped with Non-contact displacement sensor



Example of 3D form comparison

เครื่องวัดชิ้นงานละเอียด



· A multi-sensor measuring machine equipped with an imaging optical head and non-contact displacement sensor. Both vision measurement and non-contact form measurement are possible.



Features: HYBRID TYPE1

- The focusing point method minimizes the difference in the measuring face reflectance and achieves high measurement reproducibility.
- · Capable of measuring detailed shapes in high resolution.

• The laser probe equipped HYBRID TYPE1 and CPS probe equipped HYBRID TYPE4 are available.



Features: HYBRID TYPE4

- · Enables detection of high inclination angles for both mirror and diffused Surfaces.
- · The automatic lighting adjustment function allows for high accuracy measurements.
- · Surface roughness or thickness measurement of thin and transparent objects such as film.

VISION MEASURIG SYSTEMS Vision Measuring เครื่องวัดชิ้นงาน ละเอียด

เครื่องวัดชิ้นงานละเอียด

Micro Form

Measuring System เครื่องวัดชิ้นงาน ละเอียด

Data Processing Software ซอฟแวร์

Quick Scope Series เครื่องวัดชิ้นงาน ละเอียด

Quick Image Series เครื่องวัดชิ้นงาน ละเอียด

COMMON SPECIFICATIONS for TYPE1/TYPE4

Apex / Hyper / STREAM PLUS (Specifications other than as described below are the same as for models: QV Apex, Hyper QV, and QV STREAM PLUS.)

Order No.			QVH Apex302 QVH STREAM 302	Hyper QVH302	QVH Apex404 QVH STREAM 404	Hyper QVH404	QVH Apex606 QVH STREAM 606	Hyper QVH606		
	by vision probe		300x200x	(200 mm	400x400x	(250 mm	600x650x250 mm			
Measuring Accuracy (XxYxZ) by displacement		TYPE1	180x200x	k200 mm	280x400x	250 mm	480x650x250 mm			
(70.7.7.2)	sensor	TYPE4	176x200x	k200 mm	276x400x	(250 mm	476x650x250 mm			
	E1	E1X, E1Y	(1.5+3L/1000)μm	(0.8+2L/1000)µm	(1.5+3L/1000)µm	(0.8+2L/1000) μ m	(1.5+3L/1000)µm	(0.8+2L/1000)µm		
Measuring accuracy*	E1	E1Z	(1.5+4L/1000)μm	(1.5+2L/1000)µm	(1.5+4L/1000)µm	(1.5+2L/1000) μ m	(1.5+4L/1000)µm	(1.5+2L/1000) μ m		
(Touch probe)			(2.0+4L/1000)μm (1.4+3L/1000)μm		(2.0+4L/1000)µm	(1.4+3L/1000)µm	(2.0+4L/1000)µm	(1.4+3L/1000)µm		
Displacement sensor accuracy*	E1	E1Z	(1.5+4L/1000)µm	(1.5+2L/1000)µm	(1.5+4L/1000)µm	1.5+2L/1000) μ m	(1.5+4L/1000)μm	(1.5+2L/1000)μm		

^{*} Inspected to a Mitutoyo standard. L = length between two arbitrary points (mm)

CLASS 1 LASER PRODUCT

Safety precautions regarding QV HYBRID TYPE1

This product uses a low-power visible laser (780 nm) for measurement. The laser is a CLASS 1 EN/IEC 60825-1 device. A warning and explanation label, as shown above, is attached to the product as appropriate



ละเอียด Micro Form **Measuring System**

Quick Scope Series เครื่องวัดขึ้นงาน ละเอียด

Quick Image Series เครื่องวัดขึ้นงาน ละเอียด

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เครื่องวัดชิ้นงานละเอียด

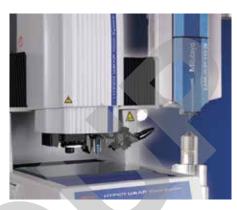
UMAP Vision System TYPE2 SERIES 364 — Micro Form Measuring System

Ultrasonic micro probe, UMAP

The ultrasonic micro probe (UMAP) has the ability to sense the amplitude variability in a micro area and the optional contact points (15 to 300µm diameter) offer a large range of high accuracy measurement meeting awide variety of

 Both high-accuracy sophisticated non-contact and contact measurement capabilities with one machine

This unit includes the UMAP and the non-contact type vision head. Until now, it was difficult to measure micro areas, but it is now possible with both contact and non-contact.

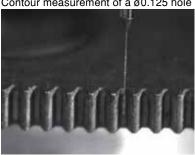


MeasurLink® ENABLED Data Management Software by Mitutoyo

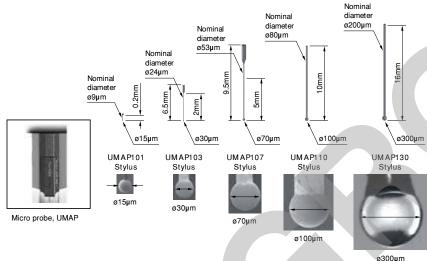
Application example



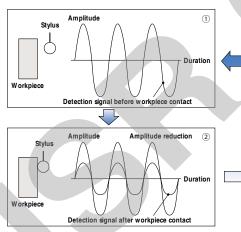
Contour measurement of a Ø0.125 hole



Measuring form of micro gear teeth



Detection of surface principle



- 1. In this drawing, the stylus is vibrating with a micro amplitude. When it does not come into contact with the workpiece as shown, the vibration state is maintained.
- 2. As the stylus comes into contact with the workpiece surface the vibration amplitude decreases as the contact increases. When the decreasing amplitude falls below a certain level, a touch-trigger signal is generated.

		TYPE2							
		Hyper UMAP302	ULTRA UMAP404						
	X-axis Y-axis	185x200mm	285x400mm						
Measuring range (common to vision and UMAP)	Z-axis	175mm: UMAP101/103 180mm: UMAP107/110 185mm: UMAP130							
Measuring accuracy	E1X, E1Y	(0.8+2L/1000)μm	(0.25+L/1000)μm						
(Vision)	E1Z	(1.5+2L/	1000)µm						
Repeatability	UMAP 101/103/107	σ = 0.1 μm	σ = 0.08μm						
	UMAP 110/130	σ = 0.15 μm	σ = 0.12 μm						

OPTICAL MEASURING

การวัดด้วยเลนส์

Mitutoyo

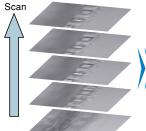
About the PFF (Points From Focus) Function

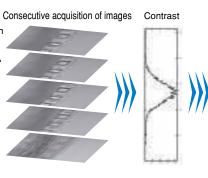
• PFF (Points From Focus) is an application that can use the image contrast of the Quick Vision Series to perform non-contact 3D form measurements. The Mitutoyo inspection method guarantees the Z-direction repetition accuracy, so it is possible to perform highly accurate form measurements.

PFF Principle

Workpiece: crown gear







3D form data composition using QV3DPAK



Software ซอฟแวร์

MICRO FORM MEASURING SYSTEM เครื่องวัดชิ้นงานละเอียด

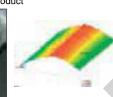
Vision Measuring System

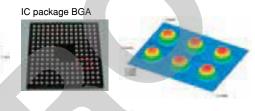
Quick Scope Series เครื่องวัดชิ้นงาน ละเอียด

Quick Image Series เครื่องวัดชิ้นงาน ละเอียด

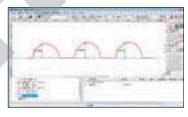
PFF Measurement Example











PFF Measurement Performance

PFF guarantees, by way of the Mitutoyo inspection method, the Z-direction repetition accuracy.

Order No.	QV Apex/QV ACCEL	Hyper QV	ULTRA QV
Z-direction repetition accuracy	2 <i>σ</i> ≦1.5 μm	2 <i>σ</i> ≦1.5 μm	2 <i>σ</i> ≦0.7 μm
Optical magnification	QV-HR2.5X	QV-HR2.5X	QV-5X
guaranteed to be accurate	+	+	+
guaranteed to be accurate	PT2X	PT2X	PT2X

Note 1: When using the PFF function, employ the QV3DPAK software and a PFF-compatible objective.

Note 2: The PFF-compatible models are the PRO versions of the machines listed in the table above (including TP, HYBRID and UMAP machines).

Vision Measuring

System เครื่องวัดชิ้นงาน

ละเอียด

Micro Form

Measuring System เครื่องวัดชิ้นงาน ละเอียด **Data Processing**

Quick Scope Series เครื่องวัดขึ้นงาน

Quick Image Series เครื่องวัดชิ้นงาน ละเอียด

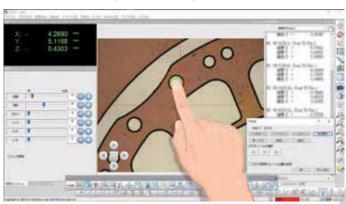
ละเอียด

Mitutoyo

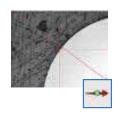
ซอฟแวร์

Data Processing Software for QUICK VISION

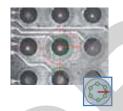
• The X, Y, and Z position data is detected from the measurement data gathered by the Quick Vision system and the arithmetic processing of coordinates and dimensions is performed immediately.

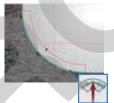


Edge Detection Tools









Point Tool This is a basic tool for detecting one point.

Line Tool

This tool detects linear edges with a minimum of one pixel space. Compared to the point tool, the line tool can perform averaging and remove abnormal points, which enables stable measurements

Circle Tool

This tool detects circular edges with a minimum of one pixel space. Edges can be specified easily with a single click.

Arc Tool

This tool is suited to detection of arcs and corner radii.



Maximum / Minimum

This tool detects the maximum or minimum point within the range.



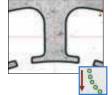
Area Centroid Tool

This tool detects the position of a form's centroid, and is suited to the positioning of different forms.



Pattern Search Tool

This tool performs pattern matching to detect a position, and is optimal for positioning alignment marks and similar tasks.



Auto Trace Tool

This is a shape-measuring tool that automatically tracks a contour with input consisting only of a start point and end point.

MeasurLink® ENABLED Data Management Software by Mitutoyo



Application software (Options)

QV PartManagerThe QV PartManager is execution program management software for multiple workpieces arranged on the measuring stage.

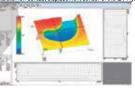
Form assessment/analysis software FORMTRACEPAK-AP

Verification of designed value and form analysis are performed on the basis of the contour data obtained via the QV auto trace tool, non-contact displacement sensor, PFF, and WLII.



FORMTRACEPAK-PRO

software performs 3D form analysis from the data obtained non-contact displacement sensor of the QV Hybrid series



QV3DPAK

This software generates 3D forms from the PFF (Points From Focus) or WLI (White Light Interferometer) data.



ment support software QV3DCAD-OnLine

This software creates QVPAK measurement procedure programs using 3D CAD data. This allows users to reduce the program creation manhours needed and shorten lead times.



QV-CAD I/F

This software displays CAD data in the graphic window to improve measurement operability.



Off-line teaching software EASYPAG PRO

EASTPAG PHO
This software creates QVPAK measurement procedure programs using 2D CAD data. This allows users to reduce the program creation man-hours needed and shorten lead times.

Test chart software/Statistical processing software MeasureReportQV

This software creates an inspection report from the QV measurement results.

MeasurLinkThis software enables statistical arithmetic processing of measurement results.

External control software

QVELIO This is dilent application software that can externally control QVPAK or provide the operating status of QVPAK by connecting a PLC or remote software on an external PC. This software can be used for connecting an automatic transfer robot to a signal tower.

Mitutoyo

MeasurLink® ENABLED

Data Management Software by Mitutoyo

QUICK SCOPE SERIES

เครื่องวัดชิ้นงานละเอียด QS-LZ / AFC

Manual Vision Measuring System

- This is a manual vision measuring machine equipped with a color camera and zoom lens.
- The Quick Release System on the stage enables rapid relocation and fine adjustment of the measuring point, which is a real time saver when working with large dimensions.
- A control box provides convenient access to the frequently used functions including illumination setting, zero-clear of the counter and auto focusing.
 An auto-focus system is fitted and noncontact height measurement is possible.

 Accuracy Ed. (4, 5, 6), (1000), (m) is guaranteed.
- Accuracy of E1z (4.5+6L/1000) μ m is guaranteed.



Model No.	QS-L2010Z/AFC	QS-L3017Z/AFC	QS-L4020Z/AFC						
Drive method	Autofocus equipped, X-, Y-axis: manual; Z axis: motor-operated								
Optical magnification	Zoom 0.5X to 3.5X (8 steps with 1.5X and 2X objectives)								
Total magnification *1	Co-axial light, stage light, 4-quadrant ring light, white LED								
Measuring range (X Y Z)	200x100x150 mm	300x170x150 mm	400x200x150 mm						
Image detection method	3 megapixel, Color CCD camera								
Indication accuracy *1 X axis, Y axis		(2.2+20L/1000)µm							
Z axis		(4.5+6L/1000)μm	<u> </u>						

^{*1:} Specification applicable to 20°C, zoom magnification 2.5X.

From wide view measurement to micro-measurement

Optical	magnifi cation	0.5X	0.65X	0.75X	0.85X	0.98X	1X	1.28X	1.3X	1.5X	1.7X	2X	2.25X	2.5X	ЗХ	3.5X	3.75X	4X	5X	5.25X	7X
View fie (mm)	eld Horizontal (H) Vertical (V)	13.60 10. 80	10.46 8.31	9.07 7.20	8.00 6.35	6.94 5.51	6.80 5.40	5.31 4.22	5.23 4.15	4.53 3.60	4.00 3.18	3.40 2.70	3.02 2.40	2.72 2.16	2.27 1.80	1.94 1.54	1.81 1.44	1.70 1.35	1.36 1.08	1.30 1.03	0.97 0.77
lens	1X objective (optional) Working distance	•	•		•		•	74	mm	•		•		•		•					
Objective le	1.5X objective (standard accessory) Working distance			•		•		•		•	42	mm	•		•		•			•	
ð	2X objective (optional) Working distance						•		•		•	•	42	mm	•			•	•		•

Vision Measuring เครื่องวัดชิ้นงาน

ละเอียด

Micro Form Measuring System เครื่องวัดชิ้นงาน

Data Processing Software ซอฟแวร์

ละเอียด

Quick Scope Series

เครื่องวัดชิ้นงาน ละเอียด

Vision Measuring

เครื่องวัดชิ้นงาน

ละเอียด

Micro Form **Measuring System** เครื่องวัดขึ้นงาน ละเอียด **Data Processing** Software ซอฟแวร์ **Quick Scope Series** เครื่องวัดขึ้นงาน ละเอียด **Quick Image Series**

ละเอียด

Mitutoyo

เครื่องวัดชิ้นงานละเอียด

Quick Image

Non-contact 2D Vision Measuring System



- This series of manual 2D vision measuring machines offers high-efficiency measurement by employing a telecentric optical system that has a deep focal depth and a wide view monitor.
 The stitching function enables the entire display of a large
 - workpiece so that highly accurate and speedy measurement
 - can be performed.

 A model equipped with a motorized stage has been added to the series to offer easy and comfortable stage operation.
- A single click enables multiple measurements in one display. A batch measurement can be applied to multiple workpieces in the display after executing a pattern search based on the workpiece position.
- This series is equipped with a megapixel color camera. Even
- with low magnification, high repeatability can be obtained.

 The choice of five stage sizes makes it easy to choose a
- machine to suit the users's application.

 The video window automatically displays the measuring machine, which enables quick verification





QI-C2017D

			M	anual stage mod	Mot	torized stage me	odel		
0.2X	Order No.	QI-A1010D	QI-A2010D	QI-A2017D	QI-A3017D	QI-A4020D	QI-C2010D	QI-C2017D	QI-C3017D
0.5X	Order No.	QI-B1010D	QI-B2010D	QI-B2017D	QI-B3017D	QI-B4020D			
Measuring ran	nge (X Y)	100x100 mm	200x100 mm	200x170 mm	300 170 mm	400x200 mm	200x100 mm	200x170 mm	300x170 mm
Effective stage	e glass size	170x170 mm	242x140 mm	260x230 mm	360x230 mm	440x232 mm	242x140 mm	260x230 mm	360x230 mm
Maximum stage loading *		Approx	c. 10 kg	Approx	c. 20 kg	Approx. 15 kg	Approx. 10 kg	Approx	c. 20 kg
Main unit mas	is	Approx. 65 kg	Approx. 69 kg	Approx. 150 kg	Approx. 158 kg	Approx. 164 kg	Approx. 72 kg	Approx. 153 kg	Approx. 161 kg

^{*} Does not include extremely offset or concentrated loads

0 I N			014/010	01.0						
Order No.			QI-A / QI-C	QI-B						
View field			32 24 mm	12.8 9.6 mm						
Measurement m	ode		High resolution mode / Normal mode *4							
Travel range (Z	axis)		100 m	nm						
	Measurement accuracy	High resolution mode	±2 μm	±1.5 μm						
	within the screen *1	Normal mode	±4 μm	±3 μm						
Accuracy	Repeatability within the	High resolution mode	±1 μm	±0.7 μm						
	screen (±2σ) *2	Normal mode	±2 μm	±1 μ m						
	Measurement accuracy (E1xy) *1	(3.5+0.02) m L: arbitrary measuring length (mm)							
Monitor magnific	ation *3		7.6X	18.9X						
	Magnification (Telecentric	Optical System)	0.2X	0.5X						
Ontinal system	Donath of the same	High resolution mode	±0.6 mm	±0.6 mm						
Optical system	Depth of focus	Normal mode	±11 mm	±1.8 mm						
	Working distance		90 mm							
Camera			3 megapixel, 1/2 inch, full color							
			Transmitted light: Green LED telecentric illumination							
Illumination			Co-axial light: White LED							
			Ring light: 4-quadrant white LED							
Power supply			100-240 VAC 50/60 Hz							
Accuracy guaran	nteed temperature range		20±1	[®] C						

^{*1:} Inspected to Mitutoyo standards by focus point position.
*2: The measuring accuracy is guaranteed to be accurate within the depth of focus.
*3: For 1X digital zoom (when using a 22-inch-wide monitor)
*4: Patent registered (Japan)